



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

March 19, 2026

IGI Report Number

Description

Shape and Cutting Style

Measurements

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

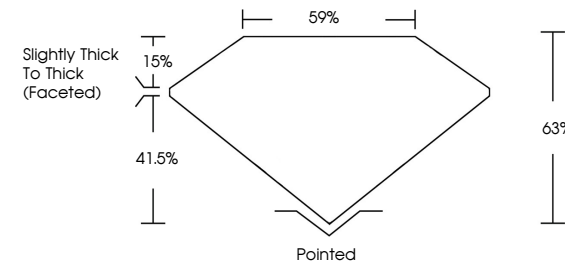
Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

LG784651263

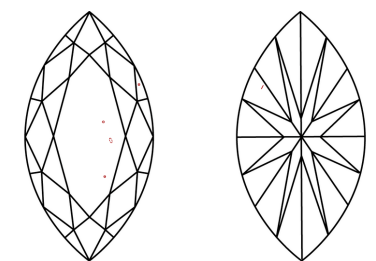
Report verification at [igi.org](#)

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

FL

IF

VVS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Flawless

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included

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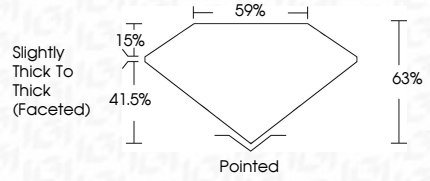
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IGI



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MARQUISE BRILLIANT

11.85 X 5.89 X 3.71 MM

Carat Weight

Color Grade

Clarity Grade

Depth

Girdle

Slightly Thick To Thick (Faceted)

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

1.51 CARAT

E

VS 2

63%

59%

Pointed

EXCELLENT

EXCELLENT

NONE

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